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IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :

YASUTAKA ITO, ET AL. :

EXAMINER: S. T. FUQUA

SERIAL NO: 10/088,098 :

FILED: MAY 30, 2002 :

GROUP ART UNIT: 3742

FOR: CERAMIC SUBSTRATE FOR
SEMICONDUCTOR
MANUFACTURE/INSPECTION
APPARATUS, CERAMIC HEATER,
ELECTROSTATIC CLAMPLESS
HOLDER, AND SUBSTRATE FOR
WAFER PROBER

RECEIVED
MAR 17 2004
TECHNOLOGY CENTER R3700

AMENDMENT

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the Office Action dated September 10, 2003, please amend the above-identified application as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

Remarks/Arguments begin on page 5 of this paper.